

Notice of References Cited	Application/Control No. 10/701,084	Applicant(s)/Patent Under Reexamination SCHWAB ET AL.	
	Examiner Cephia D. Toomer	Art Unit 1714	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-6,447,557	09-2002	Yeh et al.	44/437
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	K	US-			
	L	US-			
	M	US-			

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NON-PATENT DOCUMENTS

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